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PTC/SB/21 (09-04)
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U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 10/625,166 TRANSMITTAL Filing Date July 22, 2003 First Named Inventor **FORM** Janos Fucsko Art Unit 2813 Examiner Name Stephen W. Smoot (to be used for all correspondence after initial filing) Attorney Docket Number MI22-2246 Total Number of Pages in This Submission **ENCLOSURES** (Check all that apply) After Allowance Communication to TC Fee Transmittal Form Drawing(s) Appeal Communication to Board Fee Attached Licensing-related Papers of Appeals and Interferences Appeal Communication to TC Amendment/Reply Petition (Appeal Notice, Brief, Reply Brief) Petition to Convert to a Provisional Application Proprietary Information After Final Power of Attorney, Revocation Affidavits/declaration(s) Status Letter Change of Correspondence Address Other Enclosure(s) (please Identify Terminal Disclaimer Extension of Time Request below): Statement of the Substance of the Interview Request for Refund Express Abandonment Request CD, Number of CD(s) Information Disclosure Statement Landscape Table on CD Certified Copy of Priority Remarks Document(s) Customer No. 021567. Reply to Missing Parts/ NO FEE REQUIRED. Incomplete Application However, should it be determined that a fee is due and owing, please charge such fee for any Reply to Missing Parts item(s) checked above, to Deposit Account No. 23-0925. under 37 CFR 1.52 or 1,53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm Name Wells St. John P.S. Signature Printed name Mark S. Matkin Date Reg. No. 11-22-01 32,268 CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below: Facsimile/flumber: (571)273-8300 ( Signature

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiatity is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the Individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing its burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	10/625,166
Filing Date	July 22, 2003
Inventor	Janos Fucsko et al.
Assignee	Micron Technology, Inc.
Group Art Unit	2813
Examiner	Stephen W. Smoot
Attorney's Docket No	MI22-2246
Customer No	
Title: Wet Etching Method of Ren	noving Silicon From a Substrate

### STATEMENT OF THE SUBSTANCE OF THE INTERVIEW

To:

Mail Stop Amendment Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

VIA FACSIMILE

From:

Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)

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An interview was conducted between the undersigned and Examiner Smoot on November 16, 2005.

Independent claims 1 and 31 were primarily discussed in light of the Kaji et al. reference, and also in light of the Fujiwara et al. reference. The previous Patent Office (PTO) determination of the pH of Kaji et al. solution at col.5, Ins.9-15 was discussed in light of the Declaration submitted in Applicant's last filed response which shows the actual pH to be considerably less than that determined by the PTO. The Examiner agreed to carefully consider the Declaration further in preparation of a next PTO action in this application.

Respectfully submitted,

Dated: 11-22-05

Mark S. Matkin Reg. No. 32,268